

Notice of References Cited	Application/Control No. 10/675,441	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner David Vu	Art Unit 2828	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,593,703	07-2003	Sun, Yiyong	315/224
*	B	US-5,491,386	02-1996	Eriguchi et al.	315/209R
	C	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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